



Response
200315412-1

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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Inventor: Chen, et al Confirmation No: 7658
Serial No. 10/783,849 Examiner: Mai Huong Tran
Filed: Feb 19, 2004 Group Art Unit: 2818
Title: System And Methods For Hermetic Sealing Of Post Media-Filled
MEMS Package

Commissioner for Patents
P O BOX 1450
Alexandria VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

In response to your Office Action/Restriction Requirement dated October 7,
2004; Applicants affirm the election of Group I (Claims 17-34) without traverse.

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Respectfully submitted,

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I hereby certify that this correspondence is being
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